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	Application No.	Applicant(s)	·
	10/644,292	INAZUMACHI ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Sang Y Paik	3742	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Record the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in or other appropriate comministry. This application is s	n this application. If not inclu unication will be mailed in du	ided ie course. THIS
1. This communication is responsive to			
2. The allowed claim(s) is/are 1-8.			
3. \square The drawings filed on <u>23 August 2003</u> are accepted by the	Examiner.		
 4. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 1. Cepies of the certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 1. Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMITHIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submitinformal pattent APPLICATION (PTO-152) which give also including changes required by the Notice of Draftsperson (a) including changes required by the Notice of Draftsperson (b) including changes required by the attached Examiner's Paper No./Mail Date [Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the composition of the deposit attached Examiner's comment regarding REQUIREMENT in the composition of the deposit attached Examiner's comment regarding REQUIREMENT in the deposit attached Examiner's comment regarding REQUIREMENT in the composition of the deposit attached Examiner's comment regarding REQUIREMENT in the deposit attached Examiner's comment regarding Requirement sheet in the deposit attached Examiner's comment regarding Requirement sheet in the deposit attached Examiner's comment regarding Requirement sheet in the deposit attached Examiner in the deposit attached Examiner in the	been received. been received in Application cuments have been received of this communication to file ENT of this application. Itted. Note the attached EX is reason(s) why the oath of the submitted. It is application on the header according to 37 CF is it of BIOLOGICAL MAT	on No d in this national stage application this national stage application that a reply complying with the reply complying with the reply comp	requirements NOTICE OF
 Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0: Paper No./Mail Date 8/23/03 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. ☐ Interview S Paper No. 8), 7. ☑ Examiner's	nformal Patent Application (P summary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for A	ŕ

REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance: the claimed invention is allowed over the prior art of record because the prior art does not show the claimed sealing member disposed near the peripheral section of the adhesive layer to seal the adhesive layer.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

EXAMINER' AMENDMENT/COMMENT

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

A new abstract is provided and replaced the abstract filed on 8/20/03 to arrange the text of the abstract in a single paragraph.

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Kazama et al (US 5,567,267), Wang et al (US 6,538,872), Nozawa et al (US 5,290,381), Furuya et al (US 6,084,215) and Ishii (US 5,851,298).

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Any inquiry concerning this communication or earlier communications from the 4.

examiner should be directed to Sang Y Paik whose telephone number is 703-308-1147. The

examiner can normally be reached on M-F (9:00-4:00) First Friday Off.

The fax phone number for the organization where this application or proceeding is

assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Sang Y Paik Primary Examiner
Art Unit 3742

syp

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New Abstract

A susceptor device comprises a susceptor base body, a temperature controlling section, an adhesive layer which attaches the susceptor base body and the temperature controlling section unitarily, an O-ring which is disposed near a peripheral section of the adhesive layer, a circular O-ring which is disposed on a bottom surface of the temperature controlling section, an O-ring supporting section which surrounds the temperature controlling section and compresses the O-rings on the temperature controlling section, and pushup screws which push up and fix the O-ring supporting section toward the temperature controlling section. By doing this, it is possible to protect the adhesive layer from an external environment. Also, it is possible to provide a susceptor device having a superior temperature controlling characteristics for the plate sample, operational stability, and durability.